

Docket No.: 8733.585.11-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Kyo-Seop CHOO et al.

Confirmation No.: TBA

Application No.: TBA

Group Art Unit: TBA

Filed: April 2, 2004

Examiner: TBA

For: X-RAY DETECTOR AND METHOD OF  
FABRICATING THEREFORE

Customer No.: 30827

**CLAIM FOR PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following prior foreign application filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Korea	2001-12721	March 12, 2001
Korea	2002-00160	January 3, 2002

In support of this claim, Certified copies of the corresponding Convention Application(s) were filed in prior application Serial No. 10/095,105, filed March 12, 2002.

Dated: April 2, 2004

Respectfully submitted,

By   
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